

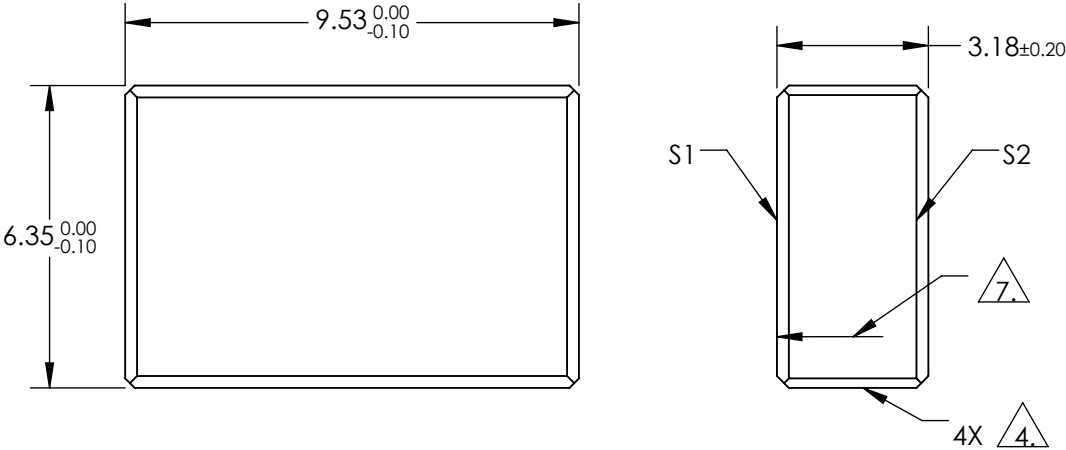
NOTES:

1. SUBSTRATE:
Fused Silica
2. SURFACE S1 TO BE PARALLEL TO SURFACE S2 TO WITHIN <3 ARCMINS
3. COATING (APPLY ACROSS COATING APERTURE)

S1: R(ABS) >99.5% @ 266nm
R(ABS) >99.5% @ 263 - 268nm
DAMAGE THRESHOLD,
PULSED: 2.5 J/cm² @ 266nm, 20ns, 20Hz
CW: 1 MW/cm² @ 266nm

S2: NONE

4. FINE GROUND SURFACE
5. CLEAR APERTURE AND COATING APERTURE ARE CENTERED ON SURFACE
6. POWER, IRREGULARITY, AND SURFACE QUALITY SPECIFICATIONS APPLY ACROSS CLEAR APERTURE
7. ARROW ON EDGE WITH LASER ETCH, PENCIL, OR PERMANENT INK POINTS TOWARDS SURFACE S1



**FOR INFORMATION ONLY:
DO NOT MANUFACTURE
PARTS TO THIS DRAWING**

SPECIFICATIONS SUBJECT TO CHANGE WITHOUT NOTICE
DIMENSIONS ARE FOR REFERENCE ONLY

	S1	S2				
SHAPE	PLANO	PLANO	THIRD ANGLE PROJECTION ALL DIMS INmm Edmund Optics® 6.35 x 9.53mm 266nm 45°, Nd:YAG Laser Line Mirror			
SURFACE QUALITY	10-5	COMMERCIAL POLISH				
SURFACE FLATNESS	0.10 WAVE	N/A				
MIN CLEAR APERTURE	5.40 x 8.10	N/A				
MIN COATING APERTURE	5.40 x 8.10	N/A				
BEVEL	PROTECTIVE AS NEEDED	PROTECTIVE AS NEEDED	DWG NO39579			
			SHEET1 OF 1			